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APPLICATION NUMBER

FILING/RECEIPT DATE

FIRST NAMED APPLICANT

ATTORNEY DOCKET NUMBER

09/866,600

30 ROCKEFELLER PLAZA

NEW YORK, NY 10112

FITZPATRICK CELLA HARPER & SCINTO

05/30/2001

Kazunori Iwamoto

862.C2246

CONFIRMATION NO. 4961

Date Mailed: 07/23/2001

FORMALITIES LETTER

OC000000006331946

IPE of

05514

SEP 1 3 2001

NOTICE TO FILE MISSING PARTS OF NONPROVISIONAL APPLICATION

FILED UNDER 37 CFR 1.53(b)

Filing Date Granted

An application number and filing date have been accorded to this application. The item(s) indicated below, however, are missing. Applicant is given **TWO MONTHS** from the date of this Notice within which to file all required items and pay any fees required below to avoid abandonment. Extensions of time may be obtained by filing a petition accompanied by the extension fee under the provisions of 37 CFR 1.136(a).

- The oath or declaration is missing.
 A properly signed oath or declaration in compliance with 37 CFR 1.63, identifying the application by the above Application Number and Filing Date, is required.
- To avoid abandonment, a late filing fee or oath or declaration surcharge as set forth in 37 CFR 1.16(e) of \$130 for a non-small entity, must be submitted with the missing items identified in this letter.
- The balance due by applicant is \$ 130.

A copy of this notice MUST be returned with the reply.

Customer Service Center

Initial Patent Examination Division (703) 308-1202

PART 2 - COPY TO BE RETURNED WITH RESPONSE

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862.C2246

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of	Examiner: Unassigned Group Art Unit: 2812
Kazunori IWAMOTO, et al.	
Application No.: 09/866,600	
Filed: May 30, 2001)
For: STAGE APPARATUS WHICH SUPPORTS INTERFEROMETER, STAGE POSITION MEASUREMENT METHOD, PROJECTION EXPOSURE APPARATUS, PROJECTION EXPOSURE APPARATUS MAINTENANCE METHOD, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND SEMICONDUCTOR MANUFACTURING FACTORY	September 13, 2001 ;) ;) ;) ;) ;) ;)

Box Missing Parts Commissioner for Patents Washington, D.C. 20231

ATTENTION: APPLICATION PROCESSING DIVISION, SPECIAL PROCESSING AND CORRESPONDENCE BRANCH

RESPONSE TO NOTICE TO FILE MISSING PARTS OF NONPROVISIONAL APPLICATION

Sir:

In response to the NOTICE TO FILE MISSING PARTS OF

NONPROVISIONAL APPLICATION mailed July 23, 2001 enclosed please find an

executed Declaration/Power of Attorney form, together with the surcharge fee of \$130.00.

Also enclosed is a copy of the NOTICE TO FILE MISSING PARTS OF

NONPROVISIONAL APPLICATION.

The Commissioner is authorized to charge any additional fees or credit any overpayment to Deposit Account No. 06-1205. Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below. Respectfully submitted, orney for Applicants Steven E. Warner Registration No. 33,326 FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200 SEW/dc DC_MAIN 71119 v 1 - 2 -Form #92